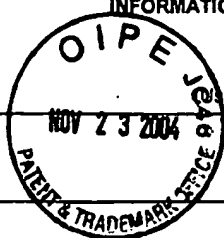


FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (See several sheets if necessary)	Docket Number: STFD.055PA	Application Number: 10/728,070
	Applicant: CHOI et al.	
	Filing Date: 12/4/2003	Group Art Unit: 1754



U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	2001	Dai, H. In <i>Carbon Nanotubes</i> ; Dresselhaus, M. S., Dresselhaus, G., Avouris, P., Eds.; Springer: Berlin, 2001; Vol. 80; pp 29-53.					
	1998	Kong, J.; Soh, H.; Cassell, A.; Quate, C. F.; Dai, H. <i>Nature</i> 1998, 395, 878-881.					
	1999	Cassell, A.; Franklin, N.; Tomblor, T.; Chan, E.; Han, J.; Dai, H. <i>J. Am. Chem. Soc.</i> 1999, 121, 7975-7976.					
	2001	Zhang, Y.; Chan, A.; Cao, J.; Wang, Q.; Kim, W.; Li, Y.; Morris, N.; Yenilmez, E.; Kong, J.; Dai, H. <i>Appl. Phys. Lett.</i> 2001, 79, 3155-3157. (abstract only)					
	2002	Ural, A.; Li, Y.; Dai, H. <i>Appl. Phys. Lett.</i> 2002, 81, 3464-3466. (abstract only)					
	1999	Soh, H.; Quate, C.; Morpurgo, A.; Marcus, C.; Kong, J.; Dai, H. <i>Appl. Phys. Lett.</i> 1999, 75, 627-629.					
	2000	Tomblor, T.; Zhou, C.; Alexeyev, L.; Kong, J.; Dai, H.; Liu, L.; Jayanthi, C.; Tang, M.; Wu, S. Y. <i>Nature</i> 2000, 405, 769-772.					
	2000	Kong, J.; Franklin, N.; Zhou, C.; Chapline, M.; Peng, S.; Cho, K.; Dai, H. <i>Science</i> 2000, 287, 622-625.					
	2000	Zhou, C.; Kong, J.; Dai, H. <i>Appl. Phys. Lett.</i> 2000, 76, 1597-1599. (abstract only)					
	2002	Cheung, C.; Kurtz, A.; Park, H.; Lieber, C. J. <i>Phys. Chem.</i> 2002, 106, 2429-2433.					
	2001	Jorio, A.; Saito, R.; Hafner, J. H.; Lieber, C. M.; Hunter, M.; McClure, T.; Dresselhaus, G.; Dresselhaus, M. S. <i>Phys. Rev. Lett.</i> 2001, 86, 1118-1121. (abstract only)					
	1998	Tans, S.; Verschueren, A.; Dekker, C. <i>Nature</i> 1998, 393, 49-52.					

EXAMINER	DATE CONSIDERED
EXAMINER: Initial reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	